HAVERSTOCK & OWENS LLP

PAIENT, TRADEMARK & COPYRIGHT ATTORNITYS

162 NORTH WOLFE ROAD SUNNYVALE, CALIFORNIA 94086 TELEPHONE (408) 530-9700 FACSIMILE (408) 530-9797

TO: Examiner Ram N. Kackar						
	USPTO - Art Unit 1763					
FROM:	Facsimile: (703) 872-9310					
	Tom Haverstock					
	HAVERSTOCK & OWENS LLP 162 North Wolfe Road					
	Sunnyvale, California 94086					
	Telephone: (408) 530-9700 Facsimile: (408) 530-9797					
Date: 10-2	3-03 Time: 1:00 a.m. (p.m.)					
Pages (includ	ling cover): 15 Client Code: Palent S/N 09/912,844					
The documents a	accompanying this facsimile transmission contains information from the law firm of HAVERSTOCK which are confidential or privileged. The information is intended to be for the use of the individual					
or entity named of distribution or us	on this cover sheet. If you are not the intended recipient, be aware that any disclosure, copying, se of the contents of this faxed information is prohibited. If you have received this facsimile in error, by telephone immediately so that we can arrange for the return of the original documents. Thank					
MESSAGE						

Serial No.: 09/912, 844 In the Mailed: 5-03-02 The following has been received in the	H&O File No.: 55/- 6 Idion of: Moxim lian A. Due Die e U.S. Patent and Trademark Office o	ate: 7-8-02
Design Patent Application	□ Form PTOL-850 (issue Fee Trans) & dup □ Form PTOL-1050 (Cert. of Correction) □ Meintenance Fee Transmittal Form □ Reexamination Request □ Noticerol-Appeal □ Addistrib/Declaration □ Copy of Feling Receipt □ Req. for Corr of: □	Continue of Melling Continue of Melling Label No: Check(s): 5 Chec

PATENT Attorney Docket No.: <u>SSI-00501</u>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Maximilian A. Biberger, et al.

Serial No.: 09/912,844

Filed: July 24, 2001

For:

HIGH PRESSURE PROCESSING

CHAMBER FOR

SEMICONDUCTOR SUBSTRATE

Group Art Unit: 2812

Examiner:

TRANSMITTAL LETTER

162 N. Wolfe Road Sunnyvale, CA 94086 (408) 530-9700

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Enclosed please find a Supplemental Information Disclosure Statement, and Form PTO-1449, including copies of the references contained thereon, for filing in the U.S. Patent and Trademark Office.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. <u>08-1275</u>. An originally executed duplicate of this transmittal is enclosed for this purpose.

Respectfully submitted, HAVERSTOCK & OWENS LLP

Dated: 5/22/02

Thomas B. Haverstock

Reg. No.: 32,571

Attorneys for Applicants

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CHEICATE OF MAILING (37 CFR \$ 1.8(a)

nereby certify that this paper (along with any arred to an being attached or enclosed) is being positive on the date, positive on the date, and below with sufficient postage as first class if in an envelope addressed to the: Assistant mmissioner for Patents, Washington D.C. 20231

HAVERSTOCK & OWENS LLP.

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OFFICIAL

Attorney Docket No.: PATENT SSI-00501

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Maximilian A. Biberger et al.

Serial No.: 09/912,844

Filed: July 24, 2001

For: HIGH PRESSURE PROCESSING CHAMBER FOR

CHAMBER FOR

Group Art Unit: 2812

Examiner:

SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT

162 N. Wolfe Road
Sunnyvale, CA 94086

(408) 530-9700

Assistant Commissioner for Patents Washington, D.C. 20231

SEMICONDUCTOR SUBSTRATE

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

Applicant has become aware of the following printed publications which may be material to the examination of this application:

- U.S. Patent No. 5,882,165;
- U.S. Patent No. 5,928,389;
- U.S. Patent No. 5,979,306;
- U.S. Patent No. 6,067,728;
- Ü.S. Patent No. 6,110,232;
- U.S. Patent No. 6,149,828;
- U.S. Patent No. 6,186,722 B1;
- U.S. Patent No. 6,235,634 B1; and
- U.S. Patent No. 6,244,121 B!.

Attorney Docket No.: SSI-00501

This Supplemental Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,

HAVERSTOCK & OWENS LLP

Dated: 5-22-02

Thomas B. Haverstock Reg. No.: 32,571

Attorneys for Applicants

JERTIFICATE OF MAILING (37 CFR § 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mall in an envelope addressed to the: Assistant Commissioner for Patents, Washington D.C. 20231

PATEN'i
Attorney Docket No.: SSI-00501

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Group Art Unit: 2812

Maximilian A. Biberger, et al.

Examiner:

Serial No.: 09/912,844

CERTIFICATION FOR

Filed: July 24, 2001

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

UNDER 37 CFR § 1.97(e)

For: HIGH PRESSURE PROCESSING

162 N. Wolfe Road

CHAMBER FOR SEMICONDUCTOR SUBSTRATES.)

Sunnyvale, CA 94086

(408) 530-9700

Assistant Commissioner of Patents Washington, D.C. 20231

Sir:

This certification is being made for the Supplemental Information Disclosure Statement accompanying this certification.

Certification

I, the person signing below, hereby certify that the printed publications contained in the enclosed supplemental information disclosure statement were cited within an Official Action mailed on April 3, 2002. Accordingly, I hereby certify that no reference contained within this supplemental information disclosure statement was cited in a communication from a foreign patent office in a related foreign application, and, to the knowledge of the person signing the statement, after making reasonable inquiry, no reference contained within this supplemental information disclosure statement was known to any individual designated in §1.56(c) more than three months prior to the filing of this supplemental information disclosure statement. 37 C.F.R. 1.97(e)(2).

PATENT Attorney Docket No.: <u>SSI-00501</u>

Identification of Person Making Certification

The person making this certification is the attorney who signs below on the basis of the information in the attorney's file.

Respectfully submitted,

HAVERSTOCK & OWENS LLP

Dated: 5-22-02

Thomas B. Haverstock Reg. No.: 32,571

Attorneys for Applicants

JERTIFICATE OF MAILING (37 CFR § 1.8(a),

I hereby certify that this paper (along with any related to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Assistant Commissioner for Palents, Washington D.C. 20231

Sheet 1 of 1

FORM PTO-1449 U.S. Depurtment of Comme (Modified) Patent and Trademark Office			nt of Commerce demark Office	Attorney Docket No.	Serial No.: 09/9	: 09/912,844			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets If Necessary) (37 CFR § 1.98(b))				ICANT	Applicant: Muximilian B. Diberger et al.				
					Filing Date: July 24,	2001	Group Art Unit: 2812		
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Examiner Initials		Serial / Patent Number	Issue Date	Applicant / Patentee		Class	Subclass	Filing Date	
	AA	5,882,165	03/16/99	Ma	Maydan et al.		217	09/10/97	
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	The Mailed: 5 - 27 - 0 3 The following has been received in the Oesten Petent Application	Serial/No.: 07/9/2 944 H&O File No.: SS1- In the Matter of The Application of: Mink I Make A. I Date Mailed: S-27-03 Due Da The following has been received in the U.S. Patent and Trademark Office on ti Design Petent Application Pages Form PTO-1533 (Not. of Massing Pails) Utility Patent Application Pages Form PTO-1533 (Not. of Massing Pails) Prov. Patent Application Pages Form PTO-1650 (Cen. of Correction) Dedanation/Oath Form PTO-1650 (Cen. of Correction) Dedanation/Oath Recommination Request Assignment Notice of Appeal Snull Entity Statement Copy of Filting Recompt Information Disclosure Statement Request for Non-Publication Rescribed Topics of Request for Non-Publication Rescribed Topics of Rescribed Information Disclosure Statement Rescribed Information Rescr

PATENT Attorney Docket No.: SSI-00501

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Maximilian A. Biberger et al.

Scrial No.: 09/912,844

Filed: July 24, 2001

For: HIGH PRESSURE PROCESSING

CHAMBER FOR

SEMICONDUCTOR SUBSTRATE

Group Art Unit: 1763

Examiner: Ram N. Kackar

TRANSMITTAL LETTER

162 N. Wolfe Road Sunnyvale, CA 94086 (408) 530-9700

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313

Sir:

Enclosed please find a Supplemental Information Disclosure Statement, a Certification pursuant to 37 CFR § 1.97(e) for Information Disclosure Statement, and Form PTO-1449, including a copy of the reference contained thereon, for filing in the U.S. Patent and Trademark Office.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. <u>08-1275</u>. An originally executed duplicate of this transmittal is enclosed for this purpose.

Respectfully submitted,

HAVERSTOCK & OWENS LLP

Dated: 5/23/63

Thomas B. Haverstock

Reg. No.: 32,571

Attorneys for Applicants

CERTIFICATE OF MAILING (37 CFR § 1.8(a))

I hereby certify that this paper (along with any reterred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the:

Cemmissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

HAVERSTOCK & OWENS LLP.

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PATENT

Attorney Docket No.: SSI-00501

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Maximilian A. Biberger et-al.

Serial No.: 09/912,844

Filed: July 24, 2001

For: MICH PRI

HIGH PRESSURE PROCESSING

CHAMBER FOR

SEMICONDUCTOR SUBSTRATE

Group Art Unit: 1763

Examiner: Ram N. Kackar

CERTIFICATION FOR

SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT UNDER 37

CFR § 1.97(e)

162 North Wolfe Road Sunnyvale, CA 94086

(408) 530-9700

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This certification is being made for the Supplemental Information Disclosure Statement accompanying this certification.

Certification

I, the person signing below, hereby certify that the printed publications contained in the enclosed supplemental information disclosure statement were cited within an Official Action mailed on February 28, 2003. Accordingly, I hereby certify that no reference contained within this supplemental information disclosure statement was cited in a communication from a foreign patent office in a related foreign application, and, to the knowledge of the person signing the statement, after making reasonable inquiry, no reference contained within this supplemental information disclosure statement was known to any individual designated in §1.56(c) more than three months prior to the filing of this supplemental information disclosure statement. 37 C.F.R. 1.97(e)(2)

Attorney Docket No.: SSI-00501

Identification of Person Making Certification

The person making this certification is the attorney who signs below on the basis of the information in the attorney's file.

Respectfully submitted,

HAVERSTOCK & OWENS LLP

Thomas B. Haverstock Reg. No.: 32,571

Attomeys for Applicants

CERTIFICATE OF MAILING (37 CFR § 1.8(a)) I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the:

Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

-2-

Attorney Docket No.: <u>SSI-00501</u>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Maximilian A. Biberger et al.

Serial No.: 09/912,844

Filed: July 24, 2001

For HIGH PRESSURE PROCESSING

CHAMBER FOR

SEMICONDUCTOR SUBSTRATE

Group Art Unit: 1763

Examiner: Ram N. Kackar

INFORMATION DISCLOSURE STATEMENT

162 N. Wolfe Road Sunnyvale, CA 94086 (408) 530-9700

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313

Sir:

The citation listed below, copy attached, may be material to the examination of the above-identified application, and is therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make this citation of official record in this application.

Applicant has become aware of the following printed publication which may be material to the examination of this application:

U.S. Patent No. 6,319,858 B1

Attorney Docket No.: <u>PATENT</u> SSI-00501

This Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 5-23-03

y: Thomas B. Haverstoc

Reg. No.: 32,571

Attorneys for Applicants

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CERTIFICATE OF MAILING (37 CFR § 1.8(a))
I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to that Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

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HAVERSTOCK & OWENS LLP

Sheet I of I

FORM PTO-1449 U.S. Department of Commerce (Modified) U.S. Department of Commerce (Modified)			nent of Commerce	Attorney Docket No.: SSI-00501 Serial No.: 09/912,844					
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets if Necessary)				Applicant: Maximilian A. Biberger et al.					
(Use Several Sheets If Necessary) (37 CFR § L.98(b))				•	Filing Date: July 24, 2001 Group Art Unit: 1763				
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Examiner Serial / Patent Issue Date		Applicant / Patentee		Class	Subclass	Filing Date			
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